


2881

4
8/2/02
m**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231 on January 10, 2002.


Michelle J. Burke
Reg. No. 37,791

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Jerald P. Dykstra

Serial Number: 09/905,536

Filed: July 13, 2001

For: GAS CLUSTER ION BEAM SIZE DIAGNOSTICS AND WORKPIECE PROCESSING

Examiner: N/A

Group Art Unit: 2881

PERKINS, SMITH & COHEN, LLP
One Beacon Street
Boston, MA 02108
(617) 854-4000

To: Commissioner for Patents
Washington D.C. 20231-0001

RECEIVED
FEB - 5 2002
TC 2800 MAIL ROOM

INFORMATION DISCLOSURE STATEMENT

Sir:

This Information Disclosure Statement (Form PTO-1449) (including copies of references) is submitted under 37 CFR 1.97(b)(3).

REMARKS

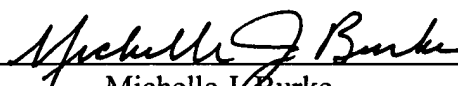
Applicant submits herewith an Information Disclosure Statement under 37 CFR 1.97(b)(3) before the mailing of a first office action on the merits. In view thereof, no fee is required, however, in the event fees are required please charge any underpayment of fees to or credit any overpayment of fees to Deposit Account No. 03-2410, Order No. 11460-111.

The following information is presented in the event that a call may be deemed desirable by the Examiner:

MICHELLE J. BURKE (617) 854-4000.

Respectfully submitted,
Jerald P. Dykstra, Applicant

Dated: 1/10/2002

By: 
Michelle J. Burke
Reg. No. 37,791
Attorney for Applicant

11469-111-IDSLETTER

